

Specification of Universal Calibration Artefact

The universal calibration artefact enables a comprehensive calibration of areal surface topography measuring instruments. The material measures included on the artefact allow a determination of the metrological characteristics according to ISO 25178-600.

As shown in Fig. 1, six different geometries are required to determine these metrological characteristics. To enable the most common microscopic magnifications from 5× to 100×, those material measures are measured with area 100 µm x 100 µm, 200 µm x 200 µm, 400 µm x 400 µm and 800 µm x 800 µm, leading to a total number of 24 potential measured areas on the sample.

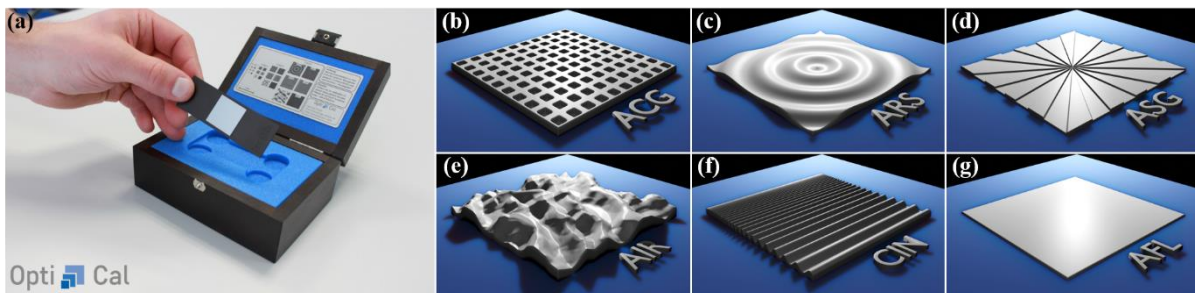


Fig. 1: Universal Calibration Artefact (schematically). (a) Sample, (b)-(g) target-geometries of the six material measures with the size of 100 µm x 100 µm, respectively.

The following material measures are included:

1) Siemens Star sample (type ASG from ISO 25178-70)

With this material measure, a measurand can be calculated which corresponds to the topographic resolution of the measuring instrument. In doing so, the spatial frequency, which is transmitted with an amplitude of 50% of the original amplitude, is determined (the spatial period limit) [2].

2) Chirped material measure (type CIN, not within current ISO)

With the chirped material measure, some aspects of the topographic fidelity can be determined, which will also be related to the topographic resolution in the ISO 25178-600 [3]. The sample with a size of 100 µm x 100 µm exhibits 16 different wavelengths between 9.46 µm and 0.47 µm.

3) Flatness material measure (type AFL from ISO 25178-70)

With the flatness material measure, instrument noise and flatness deviation can be determined. This is achieved by measuring the areal surface texture parameters as outlined in ISO 25178-700.

4) Radial sine wave (type ARS from ISO 25178-70)

With this material measure, a general calibration of all three axis of the measuring instrument is possible. Thus, the measurands S_a and S_q can be determined as stated in ISO 25178-70.

5) Cross-grating (type ACG from ISO 25178-70)

The cross-grating material measure is applied for the calibration of the lateral axis. The metrological characteristic, as defined in ISO 25178-600, is the local x-y mapping deviation. The linearity deviations l_x, l_y , amplification coefficients α_x, α_y and the perpendicularity Δ_{PERxy} of the lateral axis can also be determined.

6) Irregular rough surface (type AIR from ISO 25178-70)

The irregular rough surface is typically applied for the determination of areal amplitude-based surface texture parameters. The surface was determined by a model-based design approach and is based on an actual engineering surface [4]. Further, the functionality is extended by the calibration of the height axis [5]. This calibration of the height axis is possible by calculating the linearity deviation l_z and the amplification coefficient α_z . The parameters are determined as described within the ISO 25178-60x series. However, not a limited number of specific values is used for calibration, but the surface's linear Abbott-curve is used to determine the response curve when the measured height values are compared against the target height values with the total number of measured points. Thus, a large number of points is used for the calibration and a highly precise and practical calibration procedure results.

Tab. 1 Measurands: Shown are all metrological parameters of the material measures to be determined [1].

| type | parameter | 100 $\mu\text{m} \times 100 \mu\text{m}$ | 200 $\mu\text{m} \times 200 \mu\text{m}$ | 400 $\mu\text{m} \times 400 \mu\text{m}$ | 800 $\mu\text{m} \times 800 \mu\text{m}$ |
|------|---------------------|--|--|--|--|
| ASG | | <i>spatial period limit of the instrument</i> | | | |
| CIN | | <i>topography fidelity limit (see ISO 25178-700)</i> | | | |
| AFL | $S_a / \mu\text{m}$ | 0.000 | 0.000 | 0.000 | 0.000 |
| | $S_q / \mu\text{m}$ | 0.000 | 0.000 | 0.000 | 0.000 |
| | $S_z / \mu\text{m}$ | 0.000 | 0.000 | 0.000 | 0.000 |
| ARS | $S_a / \mu\text{m}$ | 0.944 | 0.944 | 0.945 | 0.948 |
| | $S_q / \mu\text{m}$ | 1.053 | 1.053 | 1.053 | 1.056 |
| | $l_x / \mu\text{m}$ | 10 | 20 | 40 | 80 |
| ACG | $l_y / \mu\text{m}$ | 10 | 20 | 40 | 80 |
| | $\alpha / ^\circ$ | 90 | 90 | 90 | 90 |
| | | <i>linearity deviation l_z</i> | | | |
| AIR | | <i>amplification coefficient α_z</i> | | | |
| | $S_a / \mu\text{m}$ | 2.297 | 2.297 | 2.297 | 2.297 |
| | $S_q / \mu\text{m}$ | 2.655 | 2.655 | 2.655 | 2.655 |

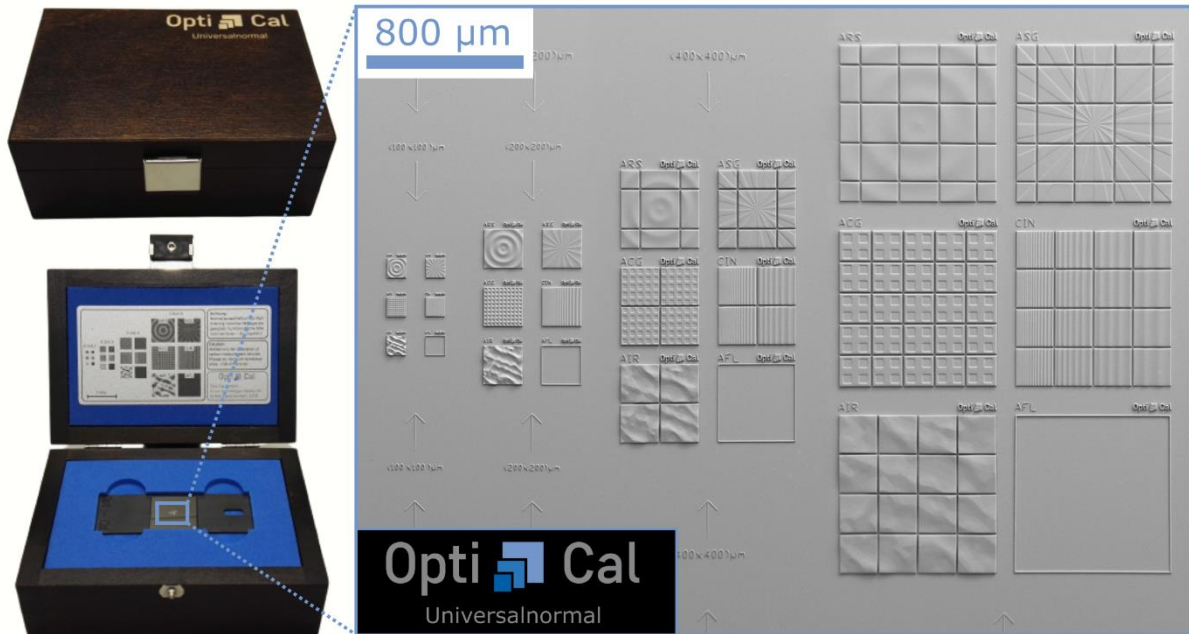


Fig. 2 Universal Calibration Artefact. Electron micrograph of the Universal Calibration Artefact to visualize the arrangement of the individual material measures.

Figure 2 gives a scanning electron microscopic overview of the arrangement of the individual material measures.

The artefact enables a calibration at different microscopic magnifications without changing the sample. The structures with the sizes of $400\ \mu\text{m} \times 400\ \mu\text{m}$ and $800\ \mu\text{m} \times 800\ \mu\text{m}$ are additionally superposed with a lateral grating in order to enable a simultaneous calibration of the lateral transfer behavior. Thus, with only one sample, many other material measures can be substituted which lead to a cost and time-efficient calibration. The metrological characteristics represent the most recent state of the art of the international standardization in the field of areal surface topography measurement. The defined measurands are summarized in Table 1. The nominal values in the table were calculated based on the target geometry for manufacturing.

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Literature

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